

RECEIVED  
CENTRAL FAX CENTER

JUL 13 2009

Dkt. 2271/75845

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Shunichi SATO and Akihiro ITOH

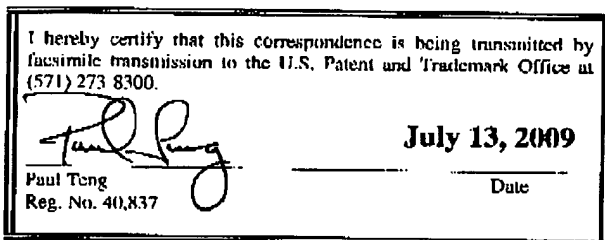
Serial No.: 10/567,809

Group Art Unit: 2828

Date Filed: June 8, 2005

Examiner: Kinam Park

For: SURFACE-EMISSION LASER DIODE AND FABRICATION PROCESS THEREOF

30 Rockefeller Plaza, 20<sup>th</sup> Floor  
New York, New York 10112  
Tel.: (212) 278-0400Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450AMENDMENT

Sir:

This Amendment is submitted in response to the Office Action dated April 21, 2009 in connection with the above-identified application.

Amendments to the Claims are reflected in the **Listing of Claims** beginning on page 2.

**Remarks** begin on page 5 of this paper.